

## PX 100

### *compact 1-axis translation stage*

#### **Concept:**

The systems of the series PX 100 are ideally suited for nm-precise positioning of optic components such as mirrors and laser diodes, adjustment and mounting in semiconductor technologies and electronics, and applications in measurement technologies and quality assurance as well as microbiology.

The series PX consist of piezo electrical actuator in stage design with a solid top and bottom plate for easily integration in optical setups. The monolithic flexure hinges design offers high precision motion range, high stiffness and in due of this excellent dynamical performance for extremely fast and accurate positioning tasks

#### **Specials:**

The systems of this series are available in vacuum and cryogenic temperature configurations.

As an option they may come equipped with strain gage or capacitive position sensors, depending on the system configuration, to achieve very accurate repeatability in the low nanometer range.

#### **Interfaces:**

The elements of the series PX are actuators integrated with an inner lever transmission in housing. Since the lever mechanism works in both directions, pulling forces between bottom and top plate need to be avoided, as they could damage the stage. The stage is fixed to a base plate.

Components can be mounted on the top plate by two threaded diagonal holes and can be accurately affixed using the precise pin holes.



image: PX 100

#### *Product highlights:*

- accurate parallel motion
- up to 100µm motion range
- without mechanical play
- easily combined with other piezo electrical systems
- precision pin holes for accurate adjustment
- high dynamic range

#### *Applications:*

- fiber positioning
- beam alignment
- semiconductor
- micro manipulation

## PX 100

### Technical data:

linear positioning stage	unit	PX 100	PX 100 SG
<b>part no.</b>		T-104-00	T-104-01
<b>axis</b>	-	X	X
<b>motion in open(±10%)/closed loop (±0.2%)*</b>	µm	100/ -	100/80
<b>capacitance (±20%)**</b>	µF	1.8	1.8
<b>resolution (open/closed loop)***</b>	nm	0.2/ -	0.2/2
<b>integrated measurement system</b>	-	-	strain gage
<b>typ. repeatability</b>	nm	-	±4
<b>typ. non-linearity</b>	%	-	0.02
<b>resonant frequency (unloaded)</b>	Hz	790	790
<b>max. push/pull forces</b>	N	150/15	150/15
<b>stiffness</b>	N/µm	0.35	0.35
<b>voltage range</b>	V	-20...130V	-20...130V
<b>connector (additional variation please see table below) ****</b>	-	LEMO 0S.302	LEMO 0S.302/ LEMO 0S.304
<b>cable length</b>	m	1	1.2
<b>min. bend radius of cable</b>	mm	15	15
<b>temperature range</b>	°C	-20°C ... +80°C	-20°C ... +80°C
<b>material</b>	-	aluminum/stainless steel	
<b>dimensions (LxWxH)</b>	mm	40x40x20	40x40x20
<b>weight</b>	g	85	90

\* typical value measured with NV 40/3 amplifier (closed loop: NV 40/3 CLE amplifier )

\*\* typical value for small electrical field strength

\*\*\* the resolution is only limited by the noise of the power amplifier and metrology

\*\*\*\* additional connector configurations

Product name	Description	Specials	Part. No Suffix.
PX 100 SG Digital	Version for digital controller series d-Drive and 30DV50 in combination with additional functionalities: Interchangeability, ASI, ASC	Connector Sub-D 15	T-104-01D
PX 100 SG Extern	Version with sensor pre-amplifier for the use with „CLE“ amplifier units and with the additional functionalities: Interchangeability, ASI	Connector Sensor: ODU 4pin	T-104-01E

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